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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YUKIKO IWASAKI ET AL.

Application No.: 10/083,585

Filed: February 27, 2002

For: METHOD FOR  
MANUFACTURING A  
SEMICONDUCTOR FILM

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Examiner: Asok K. Sarkar  
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Group Art Unit: 2829  
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:  
April 28, 2003

Commissioner for Patents  
Washington, D.C. 20231

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RESPONSE TO RESTRICTION REQUIREMENT

Sir:

The Office Action dated March 26, 2003 states that the above-identified application is required to be restricted to one of the following patentably distinct species of the claimed invention:

- Species I: (Claims 1-12), directed to a method for manufacturing a semiconductor film by bonding a second member, which is hardly heated by induction heating;
- Species II: (Claims 13-24), directed to a method for manufacturing a semiconductor film by bonding a second member, whose resistivity is higher than the substrate;

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

April 28, 2003.

(Date of Deposit)

Justin D. Petruzzelli

(Name)

*Justin D. Petruzzelli*  
Signature

April 28, 2003

Date of Signature

Species III: (Claims 25-39), directed to a method for manufacturing a semiconductor film by preparing a member consisting of a substrate and a semiconductor layer having resistivity higher than the substrate;

Species IV: (Claims 40-48), directed to a method for manufacturing a solar cell; and

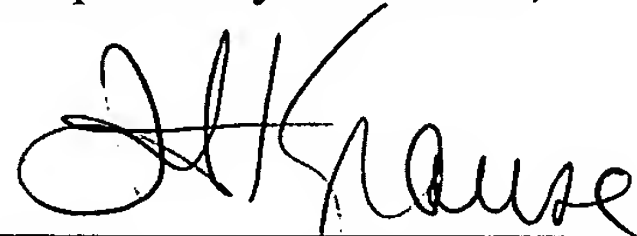
Species V: (Claims 49-58), directed to a method for manufacturing an SOI substrate.

In response, Applicants elect, without traverse, to prosecute Claims 25-39 of Species III in the present application.

An early and favorable examination on the merits is respectfully requested.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No. 24,613

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FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200